

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hongyong Zhang Art Unit : 2814
Serial No. : 09/362,808 Examiner : Shrinivas H. Rao
Filed : July 28, 1999 Conf. No. : 7320
Title : METHOD OF FABRICATING SEMICONDUCTOR DEVICE

MAIL STOP RCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Applicants request consideration of the references listed on the attached PTO-1449 form. Under 37 C.F.R. § 1.98 (a)(2)(ii), only copies of foreign patent documents and/or non-patent literature are enclosed. Copies of any listed U.S. patents or U.S. patent application publications can be provided upon request.

The references included in this information disclosure statement were cited in U.S. Application Serial No. 11/275,021, which is directed to subject matter similar to that of the present application.

This filing is being made with the filing of a Request for Continued Examination. No fee is required.

Respectfully submitted,

Date: 10/31/07


John F. Hayden
Reg. No. 37,640

Customer No. 26171
Fish & Richardson P.C.
1425 K Street, N.W. - 11th Floor
Washington, DC 20005-3500
Telephone: (202) 783-5070
Facsimile: (202) 783-2331
/adt
40454856.doc